

 <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <small>(USE SEVERAL SHEETS IF NECESSARY)</small>	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. SAEG128.002AUS	APPLICATION NO. 10/602,906
	APPLICANT Takashi MIYOSHI		
	FILING DATE June 24, 2003	GROUP <u>Unknown</u>	1751

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
1							
2							
3							
4							
5							

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES
JT	6	JP1994-175144A	06/24/94	Japan	—	—	X
JT	7	JP 2002-175733	06/21/02	Japan	—	—	X
	8						
	9						
	10						
	11						

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
JT	12	Furusaki, et al., "Preparation of ITO Thin Films by Sol-Gel Method," Journal of the Ceramic Society of Japan 102[2] page 200-205 (1994)
	13	
	14	
	15	
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EXAMINER /Jaison Thomas/	DATE CONSIDERED 09/12/2006
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 608; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	